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CENTRAL FAX CENTER****AUG 07 2006****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re:	Detlef Michelsson	Confirmation No:	3203
Application No:	10/774,520	Group:	2877
Filed:	February 9, 2004	Examiner:	Allawi, Ali
For:	Method and apparatus for scanning a semiconductor wafer		
Customer No.:	29127		
Attorney Docket No.	21295.73 (H5749US)		

**AMENDMENT AND REPLY**

Mail Stop Amendment  
**Commissioner for Patents**  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the pending Office Action, mailed March 7, 2006 (Paper No. 20060306), please amend the above-captioned application as follows:

-amendments to the claims are reflected in the listing of claims in section a);

Finally, reconsideration is requested in view of the remarks set forth in section b).

08/09/2006 HTECKLU1 00000029 502233 10774520  
01 FC:1252 450.00 DA